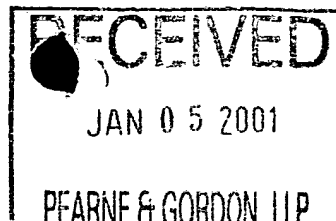




## UNITED STATES PATENT AND TRADEMARK OFFICE

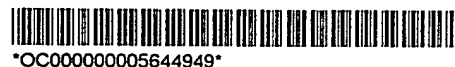
82V  
Page 1 of 3COMMISSIONER FOR PATENTS  
UNITED STATES PATENT AND TRADEMARK OFFICE  
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APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLAIMS	IND CLAIMS
09/673,005	11/27/2000	1742	1260	33019	5	15	1

Pearne Gordon McCoy & Granger  
Suite 1200  
526 Superior Avenue East  
Cleveland, OH 44114-1484



## FILING RECEIPT



\*OC000000005644949\*

Date Mailed: 12/29/2000

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the PTO processes the reply to the Notice, the PTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

## Applicant(s)

Emmanuel Hadji, Fontaine, FRANCE;  
Jean-Louis Pautrat, Grenobbb, FRANCE;  
GRENOBLE

## Continuing Data as Claimed by Applicant

THIS APPLICATION IS A 371 OF PCT/FR00/00278 02/07/2000

## Foreign Applications

FRANCE 99 01559 02/10/1999

If Required, Foreign Filing License Granted 12/29/2000

## Title

Method for forming an optical silicon layer on a support and use of said method in the production of optical components

## Preliminary Class

427

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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Emmanuel Hadji et al.  
Serial No.: 09/673,005 Art Unit: 1742  
Filed: November 27, 2000  
Title: METHOD FOR FORMING AN OPTICAL SILICON LAYER ON A SUPPORT  
AND USE OF SAID METHOD IN THE PRODUCTION OF OPTICAL  
COMPONENTS  
Docket No.: 33019

LETTER REQUESTING  
CORRECTED FILING RECEIPT

Asst. Commissioner of Patents  
Office of Initial Patent Examination  
Customer Service Center  
Washington, D.C. 20231

Sir/Madam:

Enclosed is a copy of the Official Filing Receipt for the above-identified application. The receipt contains an error in the "Applicant(s)" section of the receipt. The section should read as follows:

Applicant(s)  
Emmanuel Hadji, Fontaine, FRANCE  
Jean-Louis Pautrat, Grenoble, FRANCE

Please issue a corrected filing receipt for this application and forward the same to the undersigned attorney of record.

Respectfully submitted,

PEARNE & GORDON LLP

By   
Jeffrey J. Sopko, Reg. No. 27676

526 Superior Avenue, East  
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January 16, 2001

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231 on the date indicated below.

Jeffrey J. Sopko  
Name of Attorney for Applicant(s)  
1/16/01  
Date Signature of Attorney

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